

Message Text

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PAGE 01 STATE 154921
ORIGIN COME-00

INFO OCT-01 EA-12 ISO-00 EB-08 /021 R

DRAFTED BY COM/BIE PR/OCA/JPN/CJOHNSON
APPROVED BY EA/J:RKILPATRICK
COM/BDBD/SPADWO
STATE/EA/J/HVOCHRAN
EB:OT:TA:JCUNNINGHAM0
EA/EP:DASTEB ING (INFO)

-----119814 171652Z /43

R 171350Z JUN 78
FM SECSTATE WASHDC
TO AMEMBASSY TOKYO

UNCLAS STATE 154921

E.O. 11652: N/A

TAGS: ETRD, JA

SUBJECT: VISIT OF SEMICONDUCTOR INDUSTRY ASSOCIATION (SIA)
STUDY PROJECT DIRECTOR

REF: STATE 139810

1. JOHN VAN SAUN, SIA STUDY PROJECT DIRECTOR, PLANS VISIT
TOKYO JULY 1-14 TO DISCUSS WITH MINISTER BUTTON, JIM
BALLOUN (ACJ) AND OTHERS SIA STUDY PROJECT, INCLUDING
ROLE OF TOKYO TRADE STUDY GROUP (TSG). EMBASSY REQUESTED
PROVIDE FULL ASSISTANCE.

2. ACCORDING TO VAN SAUN, BALLOUN AND EMBASSY (OSTERMAN)
PREPARING "BLACK BOOK" DESCRIBING TSG AND ITS WORK,
INCLUDING TWO COMPLETED CASE STUDIES. VAN SAUN SAYS
"BLACK BOOK" NEEDED HERE ASAP FOR BACKGROUND INFORMATION
OF SIA. PLEASE SEND TO COMMERCE DEPARTMENT, C/O
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CHADWICK JOHNSON (ITA/BIEPR/OCA), FOR TRANSMITTAL TO
VAN SAUN IF POSSIBLE PRIOR HIS DEPARTURE FOR TOKYO. NEWSOM

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NNN

Message Attributes

Automatic Decaptioning: X
Capture Date: 01 jan 1994
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: INDUSTRY, VISITS
Control Number: n/a
Copy: SINGLE
Draft Date: 17 jun 1978
Decaption Date: 01 jan 1960
Decaption Note:
Disposition Action: n/a
Disposition Approved on Date:
Disposition Case Number: n/a
Disposition Comment:
Disposition Date: 01 jan 1960
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1978STATE154921
Document Source: CORE
Document Unique ID: 00
Drafter: BIE PR/OCA/JPN/CJOHNSON
Enclosure: n/a
Executive Order: N/A
Errors: N/A
Expiration:
Film Number: D780254-0326
Format: TEL
From: STATE
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1978/newtext/t19780647/aaaaboio.tel
Line Count: 57
Litigation Code IDs:
Litigation Codes:
Litigation History:
Locator: TEXT ON-LINE, ON MICROFILM
Message ID: a20dc486-c288-dd11-92da-001cc4696bcc
Office: ORIGIN COME
Original Classification: UNCLASSIFIED
Original Handling Restrictions: n/a
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 2
Previous Channel Indicators: n/a
Previous Classification: n/a
Previous Handling Restrictions: n/a
Reference: 78 STATE 139810
Retention: 0
Review Action: RELEASED, APPROVED
Review Content Flags:
Review Date: 29 mar 2005
Review Event:
Review Exemptions: n/a
Review Media Identifier:
Review Release Date: N/A
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
SAS ID: 2306872
Secure: OPEN
Status: NATIVE
Subject: VISIT OF SEMICONDUCTOR INDUSTRY ASSOCIATION (SIA) STUDY PROJECT DIRECTOR
TAGS: ETRD, JA
To: TOKYO
Type: TE
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Review Markings:
Sheryl P. Walter
Declassified/Released
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